

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PLICANT:

Spooner et al.

**SERIAL NO:** 

10/006,964

FILED:

December 5, 2001

FOR:

METHOD AND DEVICE FOR PROTECTING MICRO

ELECTROMECHANICAL SYSTEMS STRUCTURES

**DURING DICING OF A WAFER** 

Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## **CHANGE OF CORRESPONDENCE ADDRESS**

Applicant's representative requests that the correspondence address for the above application be changed to:

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Respectfully submitted,

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I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the Commissioner of Patents and Trademarks, P.Q. Box 1450, Alexandria, VA 22313-1450, Mail Stop Issue Fee.

Deborah M. Costello

Date